

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Please enter.  
/Sikyia Ip/ 04/19/2010

Application No.	:	10/549,440	Confirmation No. 5587
Applicant	:	Takesi Okabe	
371 Filed	:	September 16, 2005	
Art Unit	:	1793	
Examiner	:	Sikyia Ip	
Customer No.	:	00270	
Title	:	COPPER ALLOY SPUTTERING TARGET, PROCESS FOR PRODUCING THE SAME AND SEMICONDUCTOR ELEMENT WIRING	

Mail Stop Amendment AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL**

Sir:

This is an Amendment After Final submitted in response to a FINAL Office Action dated January 25, 2010. No new issues are raised in this Amendment After Final. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.